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Dated: September 7, 2004

Signature:

Scott E. Baxendale
(Scott E. Baxendale)

**Reply Under 37 C.F.R. § 1.116
Expedited Procedure
Art Unit: 3712**

Docket No.: 19036/37209
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yasuhiro Koizumi, et al

Application No.: 09/812,668

Group Art Unit: 1763

Filed: March 20, 2001

Examiner: Parviz Hassanzadeh

For: ION PLATING DEVICE AND ION PLATING
METHOD

AMENDMENT AFTER FINAL REJECTION PURSUANT TO 37 C.F.R. § 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This amendment is being submitted in response to the Office action dated May 5, 2004. Applicants hereby request a one-month extension of time to respond to the Office action. This response is therefore timely filed within the extended period of response as the expiration for taking action (weekend of September 4-6, 2004) were days in which the Patent Office was closed (Saturday/Sunday/Monday Labor Day Holiday), and the present response is being forwarded to the Patent Office on September 7, 2004, the next day in which the United States Patent and Trademark Office is open for business. This amendment is accompanied by a Petition for a One-Month Extension of Time and a check in the amount of \$110.00 for the requisite petition fee. Applicants respectfully request reconsideration of the application in view of the following amendments and remarks.

Please amend the above-identified application as follows:

Application No.: 09/812,668

Docket No.: 19036/37209

Amendments to the Claims are reflected in the listing of the claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 15 of this paper.